

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

<b>Title of Invention</b>	METHOD FOR MANUFACTURING TUNGSTEN/POLYSILICON WORD LINE STRUCTURE IN VERTICAL DRAM AND DEVICE MANUFACTURED THEREBY
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Application Number :

Confirmation Number:

First Named Applicant: Ramachandra Divakaruni

Attorney Docket Number: FIS920030421US1

Art Unit:

Examiner:

Search string: ( 6346734 or 6475893 or 6541810 or 6326260 or 6620677 or 6610573 or 6620676 or 20020196651 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6346734	2002-02-12	Divakaruni, et al.			
	2	6475893	2002-11-05	Giewont, et al.			
	3	6541810	2003-04-01	Divakaruni, et al.			
	4	6326260	2001-12-04	Divakaruni, et al.			
	5	6620677	2003-09-16	Hummler			
	6	6610573	2003-08-26	Weis			
	7	6620676	2003-09-16	Malik, et al.			

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020196651	2002-12-26	Weis			

## Signature

Examiner Name	Date